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CONFIRMATION NO. 7026

SERIAL NUMBER 10/593,254	FILING or 371(c) DATE 09/18/2006 RULE	CLASS 427	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. 296428US26PCT		
APPLICANTS Tsuyoshi Takahashi, Yamanashi, JAPAN; Shintaro Aoyama, Yamanashi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/06158 03/30/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-105300 03/31/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/14/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /JOSEPH ALBERT MILLER, JR/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 9	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 3
ADDRESS OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES						
TITLE Method and apparatus for forming metal silicate film, and method for manufacturing semiconductor device						
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